



#8

Docket No.: 51876P232

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of:

WON-ICK JANG, ET AL.

Application No.: 09/753,065

Filed: December 29, 2000

For:  
**STICTION-FREE MICROSTRUCTURE  
RELEASING METHOD FOR FABRICATING  
MEMS DEVICE - UTILITY**

Art Group: 1765

Examiner: Vinh, Lan

**RECEIVED**  
MAY 09 2003  
TC 1700**PETITION FOR EXTENSION OF TIME PURSUANT TO 37 C.F.R. § 1.136(a)**Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F. R. § 1.136(a), the Applicants for the above-identified application respectfully Petition the Commissioner for a one (1) month extension of time, extending the period for response to May 15, 2003, from the Final Office Action dated January 15, 2003. A check for \$55.00 (petition filing fee) is attached.

If it should be determined that a longer extension of time is required to prevent this application from being abandoned, please charge any additional fees to Deposit Account No. 02-2666. A copy of the Fee Transmittal is enclosed for deposit account charging purposes.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR &amp; ZAFMAN LLP

Date: May 05, 2003

Steven Laut, Reg. No. 47,736

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I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class mail with sufficient postage in an envelope addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on: May 05, 2003.

05/09/2003 AWONDAF1 00000013 09753065

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55.00 OP

  
Margaux Rodriguez

05-05-03

Date